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WHAT IS CLAIMED IS:

- 1. A multi-domain device, comprising:
 - first and second substrates;
- data and gate lines on the first substrate in first and second directions to define a plurality of pixel regions;
 - a pixel electrode in each pixel region, having at least one slit pattern;
 - a dielectric frame within the pixel regions on the second substrate to define a plurality of domains; and
 - a liquid crystal layer between the first and second substrates.
 - 2. The device of claim 1, further comprising a TFT in a crossing portion between the data and gate lines.
 - 3. The device of claim 1, wherein the dielectric frame is black resin.
 - 4. The device of claim 1, wherein the dielectric frame includes a material having dielectric anisotropy equal to or smaller than that of the liquid crystal layer.
- 5. The device of claim 1, wherein the dielectric frame includes photoacrylate or Benzocyclobutene(BCB).
 - 6. The device of claim 1, further comprising color filter layers and a common electrode on the second substrate.
- 30 7. The device of claim 1, further comprising a phase difference film on at least one of the first and second substrates.

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- 8. The device of claim 1, further comprising an alignment film on at least one of the first and second substrates.
- 9. The device of claim 1, wherein the liquid crystal layer includes a chiral dopant.
 - 10. A multi-domain device, comprising:

first and second substrates;

data and gate lines on the first substrate in first and second directions to define a plurality of pixel regions;

a pixel electrode in each pixel region, the pixel electrode having a plurality of holes;

a dielectric frame within the pixel regions on the second substrate to define a plurality of domains; and

- a liquid crystal layer between the first and second substrates.
- 11. The device of claim 10, wherein the dielectric frame is black resin.
- 12. The device of claim 10, wherein the dielectric frame includes photoacrylate or benzocyclobutene (BCB).
- 13. The device of claim 10, further comprising a phase 25 difference film on at least one of the first and second substrates.
 - 14. The device of claim 10, further comprising an alignment film on at least one of the first and second substrates.
 - 15. The device of claim 10, wherein the liquid crystal layer includes a chiral dopant.

16. A multi-domain liquid crystal display device, comprising:
first and second substrates;

data and gate lines on the first substrate in first and second directions to define a plurality of pixel regions;

- 5 a U shaped TFT at a crossing portion of the data and gate lines;
 - a pixel electrode in each pixel region having a plurality of holes or slit patterns;
 - a dielectric frame within the pixel regions on the second substrate to define a plurality of domains; and
 - a liquid crystal layer between the first and second substrates.
 - 17. The device of claim 16, wherein the dielectric frame is black resin.
 - 18. The device of claim 16, wherein the dielectric frame includes photoacrylate or benzocyclobutene (BCB).
 - 19. The device of claim 16, wherein the TFT includes:
 - a gate electrode on the first substrate;
 - a gate insulating film on the first substrate;
 - a semiconductor layer and an ohmic contact layer on the gate insulating film; and
- a drain electrode on the ohmic contact layer and a source electrode surrounding the drain electrode in a U shape.
 - 20. The device of claim 16, wherein the liquid crystal layer includes a chiral dopant.
 - 21. A method for manufacturing a multi-domain liquid crystal display device comprising:

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forming gate and data lines on a first substrate, the data lines being formed to cross the gate lines;

forming a passivation film on the first substrate;

forming a transparent conductive film on the passivation 5 film;

patterning the transparent conductive film to form a pixel electrode having at least one slit in a pixel region defined by the gate and data lines;

forming a dielectric frame within the pixel region to define a plurality of domains, the dielectric frame on a second substrate opposite to the first substrate; and

forming a liquid crystal layer between the first and second substrates.

- 22. The method of claim 21, wherein the step of forming the pixel electrode includes the step of patterning the transparent conductive film using a mask provided with at least one slit.
- 23. The method of claim 21, wherein the slits are formed in different directions within each domain as the plurality of domains are defined.
 - 24. The method of claim 21, wherein the dielectric frame is formed of black resin.
- 25. The method of claim 21, wherein the dielectric frame includes photoacrylate or benzocyclobutene (BCB).
- 26. The method of claim 21, wherein the step of forming the 30 liquid crystal layer includes:

forming a sealing pattern on the first substrate;

selectively dropping a liquid crystal within the sealing pattern;

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distributing a spacer on the second substrate; attaching the first and second substrate to each other; and hardening the sealing pattern by ultraviolet light.

- 5 27. The method of claim 21, wherein the liquid crystal layer includes a chiral dopant.
 - 28. A method for manufacturing a multi-domain liquid crystal display device comprising:
 - forming gate and data lines on a first substrate, the data lines being formed to cross the gate lines;

forming a passivation film on the first substrate;

forming a transparent conductive film on the passivation film;

patterning the transparent conductive film to form a pixel electrode having at least one hole in a pixel region defined by the gate and data lines;

forming a dielectric frame within the pixel region to define a plurality of domains, the dielectric frame on a second substrate opposite to the first substrate; and

forming a liquid crystal layer between the first and second substrates.

- 29. The method of claim 28, wherein the step of forming the pixel electrode includes patterning the transparent conductive film using a mask provided with at least one hole.
 - 30. The method of claim 28, wherein the dielectric frame is formed of black resin.
 - 31. The method of claim 28, wherein the dielectric frame includes photoacrylate or benzocyclobutene (BCB).

The method of claim 28, wherein the step of forming the liquid crystal layer includes:

forming a sealing pattern on the first substrate;

5 selectively dropping a liquid crystal within the sealing pattern;

> distributing a spacer on the second substrate; attaching the first and second substrate to each other; and hardening the sealing pattern by ultraviolet light.

- 33. The method of claim 28, wherein the liquid crystal layer includes a chiral dopant.
- A method for manufacturing a multi-domain liquid crystal display device comprising:

forming a TFT on a first substrate;

forming a pixel electrode having a plurality of holes or slits on an entire surface including the TFT;

forming a dielectric frame within the pixel electrode to define a plurality of domains, the dielectric frame on a second substrate opposite to the first substrate; and

forming a liquid crystal layer between the first and second substrates.

25 The method of claim 34, wherein the step of forming the TFT includes:

> forming a gate electrode on the first substrate; forming a gate insulating film on the first substrate;

forming a semiconductor layer and an ohmic contact layer on the gate insulating film; and

forming a drain electrode on the ohmic contact layer and a source electrode surrounding the drain electrode in a U shape.

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- 36. The method of claim 34, wherein the dielectric frame is formed of black resin.
- 37. The method of claim 34, wherein the dielectric frame includes photoacrylate or benzocyclobutene (BCB).
 - 38. The method of claim 34, wherein the step of forming the liquid crystal layer includes:

forming a sealing pattern on the first substrate;

selectively dropping a liquid crystal within the sealing pattern;

distributing a spacer on the second substrate; attaching the first and second substrate to each other; and hardening the sealing pattern by ultraviolet light.

- 39. The method of claim 34, further comprising forming a first electrode and a second electrode on the first substrate, the first and second electrodes forming a storage capacitor.
- 40. The method of claim 39, wherein the pixel electrode is electrically connected with the second electrode of the storage capacitor.
- 41. The method of claim 39, wherein the first electrode is formed with the gate electrode.
 - 42. The method of claim 39, wherein the step of forming the TFT includes:

forming a gate electrode on the first substrate;

forming a gate insulating film on the first substrate;

forming a semiconductor layer and an ohmic contact layer on the gate insulating film;

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forming a drain electrode on the ohmic contact layer and a source electrode surrounding the drain electrode in a U shape; and

wherein the second electrode is formed with the source and drain electrodes.

43. The method of claim 34, wherein the liquid crystal layer includes a chiral dopant.